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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PATENT**

Inventors:	Kenji OTODA, et al.	Docket No.:	49288.1600
Assignee:	Mitsuboshi Diamond Industrial Co., Ltd.		
Serial No.:	10/554,855	Confirmation No.	4197
Filing Date:	October 18, 2006	Art Unit:	3724
TITLE:	BRITTLE SUBSTRATE CUTTING SYSTEM AND BRITTLE SUBSTRATE CUTTING METHOD	Examiner:	Clark F. Dexter

DO NOT ENTER: /CD/

**AMENDMENT AND REPLY**

Mail Stop AF  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the final Office Action mailed on July 9, 2010, of which this Reply is filed within two months, please consider the following remarks and amendments.

**Amendments to the Specification** are reflected on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 20 of this paper.